## C30 **CRYSTAL GROWTH** (separation by crystallisation in general B01D 9/00) [3]

C30B SINGLE-CRYSTAL GROWTH (by using ultra-high pressure, e.g. for the formation of diamonds B01J 3/06); UNIDIRECTIONAL SOLIDIFICATION OF EUTECTIC MATERIAL OR UNIDIRECTIONAL DEMIXING OF EUTECTOID MATERIAL; REFINING BY ZONE-MELTING OF MATERIAL (zone-refining of metals or alloys C22B); PRODUCTION OF A HOMOGENEOUS POLYCRYSTALLINE MATERIAL WITH DEFINED STRUCTURE (casting of metals, casting of other substances by the same processes or devices B22D; working of plastics B29; modifying the physical structure of metals or alloys C21D, C22F); SINGLE CRYSTALS OR HOMOGENEOUS POLYCRYSTALLINE MATERIAL WITH DEFINED STRUCTURE; AFTER-TREATMENT OF SINGLE CRYSTALS OR A HOMOGENEOUS POLYCRYSTALLINE MATERIAL WITH DEFINED STRUCTURE (for producing semiconductor devices or parts thereof H01L); APPARATUS THEREFOR [3]

- (1) In this subclass, the following expressions are used with the meaning indicated:
  - "single crystal" includes also twin crystals and a predominantly single crystal product; [3]
  - "homogeneous polycrystalline material" means a material with crystal particles, all of which have the same chemical composition; [5]
  - "defined structure" means the structure of a material with grains which are oriented in a preferential way or have larger dimensions than normally obtained. [5]
- (2)
  - the preparation of single crystals or a homogeneous polycrystalline material with defined structure of particular materials or shapes is classified in the group for the process as well as in group C30B 29/00; [3]
  - an apparatus specially adapted for a specific process is classified in the appropriate group for the process. Apparatus to be used in more than one kind of process is classified in group C30B 35/00. [3]

7/08

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## Subclass index

SINGLE-CRYSTAL GROWTH	SINGLE CRYSTALS OR HOMOGENEOUS
from solids or gels	POLYCRYSTALLINE MATERIAL WITH
5/00	DEFINED STRUCTURE
from liquids7/00 to 21/00, 27/00	AFTER-TREATMENT31/00, 33/00
from vapours23/00, 25/00	APPARATUS35/00
PRODUCTION OF SINGLE CRYSTALS OR	

## Single-crystal growth from solids or gels [3]

HOMOGENEOUS POLYCRYSTALLINE

1/00	Single-crystal growth directly from the solid sta	
	(unidirectional demixing of eutectoid materials	
	C30B 3/00; under a protective fluid C30B 27/00) [3]	

MATERIAL WITH DEFINED STRUCTURE ......28/00, 30/00

1/02 . by thermal treatment, e.g. strain annealing (C30B 1/12 takes precedence) [3]

1/04 . . Isothermal recrystallisation [3]

1/06 . . Recrystallisation under a temperature gradient [3]

. . Zone recrystallisation [3] 1/08

1/10 . by solid state reactions or multi-phase diffusion [3]

1/12 . by pressure treatment during the growth [3]

3/00 Unidirectional demixing of eutectoid materials [3]

5/00 Single-crystal growth from gels (under a protective fluid C30B 27/00) [3]

. with addition of doping materials [3] 5/02

## Single-crystal growth from liquids; Unidirectional solidification of eutectic materials [3]

7/00 Single-crystal growth from solutions using solvents which are liquid at normal temperature, e.g. aqueous solutions (from molten solvents C30B 9/00; by normal or gradient freezing C30B 11/00; under a protective fluid C30B 27/00) [3]

7/02 . by evaporation of the solvent [3]

7/04 . . using aqueous solvents [3] 7/06 . . using non-aqueous solvents [3] . by cooling of the solution [3]

> . by application of pressure, e.g. hydrothermal processes [3]

. by electrolysis [3]

. the crystallising materials being formed by chemical reactions in the solution [3]

9/00 Single-crystal growth from melt solutions using molten solvents (by normal or gradient freezing C30B 11/00; by zone-melting C30B 13/00; by crystal pulling C30B 15/00; on immersed seed crystal C30B 17/00; by liquid phase epitaxial growth C30B 19/00; under a protective fluid C30B 27/00) [3]

9/02 . by evaporation of the molten solvent [3]

9/04 . by cooling of the solution [3] 9/06

. . using as solvent a component of the crystal composition [3]

9/08 . . using other solvents [3]

9/10 . . . Metal solvents [3]

9/12 . . . Salt solvents, e.g. flux growth [3]

9/14 . by electrolysis [3]

11/00	Single-crystal-growth by normal freezing or freezing under temperature gradient, e.g. Bridgman-Stockbarger method (C30B 13/00, C30B 15/00,	15/16 15/18	<ul> <li>by irradiation or electric discharge [3]</li> <li>using direct resistance heating in addition to other methods of heating, e.g. using Peltier heat [3]</li> </ul>
	C30B 17/00, C30B 19/00 take precedence; under a protective fluid C30B 27/00) [3]	15/20	• Controlling or regulating (controlling or regulating in general G05) [3]
11/02	<ul> <li>without using solvents (C30B 11/06 takes precedence) [3]</li> </ul>	15/22	Stabilisation or shape controlling of the molten zone near the pulled crystal; Controlling the
11/04	adding crystallising materials or reactants forming it		section of the crystal [3]
11/06	<ul> <li>in situ to the melt [3]</li> <li>at least one but not all components of the crystal composition being added [3]</li> </ul>	15/24	using mechanical means, e.g. shaping guides (shaping dies for edge-defined film-fed crystal growth C30B 15/34) [3]
11/08	• every component of the crystal composition being added during the crystallisation [3]	15/26	using television detectors; using photo or X-ray detectors [3]
11/10	Solid or liquid components, e.g. Verneuil method [3]	15/28	using weight changes of the crystal or the melt, e.g. flotation methods [3]
11/12	Vaporous components, e.g. vapour-liquid-solid-growth [3]	15/30	• Mechanisms for rotating or moving either the melt or the crystal (flotation methods C30B 15/28) [3]
11/14	characterised by the seed, e.g. its crystallographic	15/32	. Seed holders, e.g. chucks [3]
	orientation [3]	15/34	Edge-defined film-fed crystal growth using dies or
13/00	Single-crystal growth by zone-melting; Refining by zone-melting (C30B 17/00 takes precedence; by changing the cross-section of the treated solid	15/36	slits [3] . characterised by the seed, e.g. its crystallographic orientation [3]
	C30B 15/00; under a protective fluid C30B 27/00; for the growth of homogeneous polycrystalline material with defined structure C30B 28/00; zone-refining of specific materials, see the relevant subclasses for the	17/00	Single-crystal growth on to a seed which remains in the melt during growth, e.g. Nacken-Kyropoulos method (C30B 15/00 takes precedence) [3]
	materials) [3,5]	19/00	Liquid-phase epitaxial-layer growth [3]
13/02	. Zone-melting with a solvent, e.g. travelling solvent	19/02	. using molten solvents, e.g. flux [3]
13/04	process [3]  Homogenisation by zone-levelling [3]	19/04	<ul> <li>the solvent being a component of the crystal composition [3]</li> </ul>
13/06	<ul> <li>the molten zone not extending over the whole cross- section [3]</li> </ul>	19/06	<ul> <li>Reaction chambers; Boats for supporting the melt; Substrate holders [3]</li> </ul>
13/08	<ul> <li>adding crystallising materials or reactants forming it <u>in situ</u> to the molten zone [3]</li> </ul>	19/08	. Heating of the reaction chamber or the substrate [3]
13/10	with addition of doping materials [3]	19/10	• Controlling or regulating (controlling or regulating in general G05) [3]
13/12	in the gaseous or vapour state [3]	19/12	characterised by the substrate [3]
13/14	. Crucibles or vessels [3]	21/00	Unidirectional solidification of eutectic materials [3]
13/16	. Heating of the molten zone [3]	21/02	by normal casting or gradient freezing [3]
13/18	the heating element being in contact with, or immersed in, the molten zone [3]	21/04	by zone-melting [3]
13/20	. by induction, e.g. hot wire technique (C30B 13/18 takes precedence) [3]	21/06	. by pulling from a melt [3]
13/22	<ul> <li>by irradiation or electric discharge [3]</li> </ul>	Single-cr	ystal growth from vapours [3]
13/24	using electromagnetic waves [3]	23/00	
13/26	. Stirring of the molten zone [3]	23/00	Single-crystal growth by condensing evaporated or sublimed materials [3]
13/28	. Controlling or regulating [3]	23/02	Epitaxial-layer growth [3]
13/30	Stabilisation or shape controlling of the molten	23/04	. Pattern deposit, e.g. by using masks [3]
	zone, e.g. by concentrators, by electromagnetic fields; Controlling the section of the crystal [3]	23/06	Heating of the deposition chamber, the substrate,
13/32	. Mechanisms for moving either the charge or the heater [3]	23/08	or the materials to be evaporated [3] by condensing ionised vapours (by reactive
13/34	<ul> <li>characterised by the seed, e.g. by its crystallographic orientation [3]</li> </ul>	25/00	sputtering C30B 25/06) [3] Single-crystal growth by chemical reaction of
15/00	Single-crystal growth by pulling from a melt, e.g. Czochralski method (under a protective fluid		reactive gases, e.g. chemical vapour deposition growth [3]
	C30B 27/00) [3]	25/02	. Epitaxial-layer growth [3]
15/02	adding crystallising materials or reactants forming it	25/04 25/06	<ul><li>. Pattern deposit, e.g. by using masks [3]</li><li>. by reactive sputtering [3]</li></ul>
15/04	<ul><li>in situ to the melt [3]</li><li>adding doping materials, e.g. for n-p-</li></ul>	25/08	Reaction chambers; Selection of materials therefor [3]
15/06	junction [3]  Non-vertical pulling [3]	25/10	Heating of the reaction chamber or the
15/08	. Downward pulling [3]		substrate [3]
15/00	Crucibles or containers for supporting the melt [3]	25/12	Substrate holders or susceptors [3]
15/12	. Double crucible methods [3]	25/14	Feed and outlet means for the gases; Modifying
15/14	. Heating of the melt or the crystallised materials [3]		the flow of the reactive gases [3]

25/16	Controlling or regulating (controlling or regulating	29/48	A <sub>II</sub> B <sub>VI</sub> compounds [3]
20,10	in general G05) [3]	29/50	Cadmium sulfide [3]
25/18	characterised by the substrate [3]	29/52	Alloys [3]
25/20	• • • the substrate being of the same materials as the	29/54	Organic compounds [3]
25/22	epitaxial layer [3]	29/56	Tartrates [3]
25/22	Sandwich processes [3]	29/58	Macromolecular compounds [3]
		29/60	. characterised by shape [3]
27/00	Single-crystal growth under a protective fluid [3]	29/62	Whiskers or needles [3]
27/02	. by pulling from a melt [3]	29/64	Flat crystals, e.g. plates, strips, disks [5]
28/00	Production of homogeneous polycrystalline material with defined structure [5]	29/66	<ul> <li>Crystals of complex geometrical shape, e.g. tubes, cylinders [5]</li> </ul>
28/02	. directly from the solid state [5]	29/68	Crystals with laminate structure,
28/04	from liquids [5]		e.g. "superlattices" [5]
28/06	by normal freezing or freezing under temperature	30/00	Production of single crystals or homogeneous
20 /00	gradient [5]		polycrystalline material with defined structure
28/08	by zone-melting [5]		characterised by the action of electric or magnetic fields, wave energy or other specific physical
28/10 28/12	by pulling from a melt [5]		conditions [5]
28/12	<ul><li>directly from the gas state [5]</li><li>by chemical reaction of reactive gases [5]</li></ul>		
	•	<u>Note</u>	
29/00	Single crystals or homogeneous polycrystalline		When classifying in this group, classification is also
	material with defined structure characterised by the material or by their shape [3,5]		made in groups C30B 1/00 to C30B 28/00 according to
	material of by their shape [3,0]		the process of crystal growth. [5]
		20.102	
(1)	In groups C30B 29/02 to C30B 29/54, in the absence of	30/02	using electric fields, e.g. electrolysis [5]
(1)	an indication to the contrary, a material is classified in	30/04	. using magnetic fields [5]
	the last appropriate place. [3]	30/06 30/08	<ul> <li>using mechanical vibrations [5]</li> <li>in conditions of zero-gravity or low gravity [5]</li> </ul>
(2)	Attention is drawn to Note (3) after the title of section	30/08	. In conditions of zero-gravity of low gravity [3]
	C, which Note indicates to which version of the periodic	After-tre	eatment of single crystals or homogeneous
	table of chemical elements the IPC refers. [2010.01]		talline material with defined structure [3,5]
20 /02	El	21 /00	To 100 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1
29/02	. Elements [3]	31/00	Diffusion or doping processes for single crystals or
29/04	Diamond [3]	31/00	homogeneous polycrystalline material with defined
29/04 29/06	<ul><li>. Diamond [3]</li><li>. Silicon [3]</li></ul>	<b>31/00</b> 31/02	
29/04 29/06 29/08	<ul><li>. Diamond [3]</li><li>. Silicon [3]</li><li>. Germanium [3]</li></ul>	31/02	homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]
29/04 29/06	<ul><li>. Diamond [3]</li><li>. Silicon [3]</li></ul>		<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid</li> </ul>
29/04 29/06 29/08 29/10	<ul> <li>. Diamond [3]</li> <li>. Silicon [3]</li> <li>. Germanium [3]</li> <li>. Inorganic compounds or compositions [3]</li> </ul>	31/02 31/04	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16	<ul> <li>. Diamond [3]</li> <li>. Silicon [3]</li> <li>. Germanium [3]</li> <li>. Inorganic compounds or compositions [3]</li> <li>. Halides [3]</li> <li>. Phosphates [3]</li> <li>. Oxides [3]</li> </ul>	31/02	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14	<ul> <li>. Diamond [3]</li> <li>. Silicon [3]</li> <li>. Germanium [3]</li> <li>. Inorganic compounds or compositions [3]</li> <li>. Halides [3]</li> <li>. Phosphates [3]</li> </ul>	31/02 31/04 31/06	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20	<ul> <li>. Diamond [3]</li> <li>. Silicon [3]</li> <li>. Germanium [3]</li> <li>. Inorganic compounds or compositions [3]</li> <li>. Halides [3]</li> <li>. Phosphates [3]</li> <li>. Oxides [3]</li> <li>. Quartz [3]</li> <li>. Aluminium oxides [3]</li> </ul>	31/02 31/04	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18	<ul> <li>. Diamond [3]</li> <li>. Silicon [3]</li> <li>. Germanium [3]</li> <li>. Inorganic compounds or compositions [3]</li> <li>. Halides [3]</li> <li>. Phosphates [3]</li> <li>. Oxides [3]</li> <li>. Quartz [3]</li> <li>. Aluminium oxides [3]</li> <li>. Complex oxides [3]</li> </ul>	31/02 31/04 31/06	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20	<ul> <li>. Diamond [3]</li> <li>. Silicon [3]</li> <li>. Germanium [3]</li> <li>. Inorganic compounds or compositions [3]</li> <li>. Halides [3]</li> <li>. Phosphates [3]</li> <li>. Oxides [3]</li> <li>. Quartz [3]</li> <li>. Aluminium oxides [3]</li> <li>. Complex oxides [3]</li> <li>. with formula AMeO<sub>3</sub>, wherein A is a rare</li> </ul>	31/02 31/04 31/06 31/08 31/10	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20 29/22	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co,</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20 29/22	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20 29/22	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg,</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20 29/22	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga,</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20 29/22	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/18 29/20 29/22	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr,</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/18 31/20	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/18 31/20 31/22	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> <li>by ion-implantation [3]</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/18 31/20	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> <li>by ion-implantation [3]</li> </ul> After-treatment of single crystals or homogeneous
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates;</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/18 31/20 31/22	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> <li>by ion-implantation [3]</li> </ul> After-treatment of single crystals or homogeneous polycrystalline material with defined structure
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/18 31/20 31/22	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> <li>by ion-implantation [3]</li> </ul> After-treatment of single crystals or homogeneous
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28 29/30 29/32 29/34	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> <li>by ion-implantation [3]</li> </ul> After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5]
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28 29/30 29/32 29/34 29/36	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> <li>Carbides [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00	<ul> <li>homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]</li> <li>by contacting with diffusion materials in the solid state [3]</li> <li>by contacting with diffusion materials in the liquid state [3]</li> <li>by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]</li> <li>the diffusion materials being a compound of the elements to be diffused [3]</li> <li>Reaction chambers; Selection of materials therefor [3]</li> <li>Heating of the reaction chamber [3]</li> <li>Substrate holders or susceptors [3]</li> <li>Feed and outlet means for the gases; Modifying the flow of the gases [3]</li> <li>Controlling or regulating [3]</li> <li>Doping by irradiation with electromagnetic waves or by particle radiation [3]</li> <li>by ion-implantation [3]</li> </ul> After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5] <ul> <li>Heat treatment (C30B 33/04, C30B 33/06 take precedence) [5]</li> <li>using electric or magnetic fields or particle</li> </ul>
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28 29/30 29/32 29/34 29/36 29/38	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> <li>Carbides [3]</li> <li>Nitrides [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00 33/02	homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]  by contacting with diffusion materials in the solid state [3]  by contacting with diffusion materials in the liquid state [3]  by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]  the diffusion materials being a compound of the elements to be diffused [3]  Reaction chambers; Selection of materials therefor [3]  Heating of the reaction chamber [3]  Substrate holders or susceptors [3]  Feed and outlet means for the gases; Modifying the flow of the gases [3]  Controlling or regulating [3]  Doping by irradiation with electromagnetic waves or by particle radiation [3]  After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5]  Heat treatment (C30B 33/04, C30B 33/06 take precedence) [5]  using electric or magnetic fields or particle radiation [5]
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28 29/30 29/32 29/34 29/36 29/38 29/40	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> <li>Carbides [3]</li> <li>Nitrides [3]</li> <li>A<sub>III</sub>B<sub>V</sub> compounds [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00 33/02 33/04 33/06	homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]  by contacting with diffusion materials in the solid state [3]  by contacting with diffusion materials in the liquid state [3]  by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]  the diffusion materials being a compound of the elements to be diffused [3]  Reaction chambers; Selection of materials therefor [3]  Heating of the reaction chamber [3]  Substrate holders or susceptors [3]  Feed and outlet means for the gases; Modifying the flow of the gases [3]  Controlling or regulating [3]  Doping by irradiation with electromagnetic waves or by particle radiation [3]  hy ion-implantation [3]  After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5]  Heat treatment (C30B 33/04, C30B 33/06 take precedence) [5]  using electric or magnetic fields or particle radiation [5]  Joining of crystals [5]
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28 29/30 29/32 29/34 29/36 29/38 29/40 29/42	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> <li>Carbides [3]</li> <li>Nitrides [3]</li> <li>A<sub>III</sub>B<sub>V</sub> compounds [3]</li> <li>Gallium arsenide [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00 33/02	homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]  by contacting with diffusion materials in the solid state [3]  by contacting with diffusion materials in the liquid state [3]  by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]  the diffusion materials being a compound of the elements to be diffused [3]  Reaction chambers; Selection of materials therefor [3]  Heating of the reaction chamber [3]  Substrate holders or susceptors [3]  Feed and outlet means for the gases; Modifying the flow of the gases [3]  Controlling or regulating [3]  Doping by irradiation with electromagnetic waves or by particle radiation [3]  After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5]  Heat treatment (C30B 33/04, C30B 33/06 take precedence) [5]  using electric or magnetic fields or particle radiation [5]
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/28 29/30 29/32 29/34 29/36 29/38 29/40	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> <li>Silicates [3]</li> <li>A<sub>III</sub>B<sub>V</sub> compounds [3]</li> <li>Gallium arsenide [3]</li> <li>Gallium phosphide [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00 33/02 33/04 33/06	homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]  by contacting with diffusion materials in the solid state [3]  by contacting with diffusion materials in the liquid state [3]  by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]  the diffusion materials being a compound of the elements to be diffused [3]  Reaction chambers; Selection of materials therefor [3]  Heating of the reaction chamber [3]  Substrate holders or susceptors [3]  Feed and outlet means for the gases; Modifying the flow of the gases [3]  Controlling or regulating [3]  Doping by irradiation with electromagnetic waves or by particle radiation [3]  hy ion-implantation [3]  After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5]  Heat treatment (C30B 33/04, C30B 33/06 take precedence) [5]  using electric or magnetic fields or particle radiation [5]  Joining of crystals [5]
29/04 29/06 29/08 29/10 29/12 29/14 29/16 29/20 29/22 29/24 29/26 29/26 29/30 29/32 29/34 29/36 29/38 29/40 29/42 29/44	<ul> <li>Diamond [3]</li> <li>Silicon [3]</li> <li>Germanium [3]</li> <li>Inorganic compounds or compositions [3]</li> <li>Halides [3]</li> <li>Phosphates [3]</li> <li>Oxides [3]</li> <li>Quartz [3]</li> <li>Aluminium oxides [3]</li> <li>Complex oxides [3]</li> <li>with formula AMeO<sub>3</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co, or Al, e.g. ortho ferrites [3]</li> <li>with formula BMe<sub>2</sub>O<sub>4</sub>, wherein B is Mg, Ni, Co, Al, Zn or Cd and Me is Fe, Ga, Sc, Cr, Co, or Al [3]</li> <li>with formula A<sub>3</sub>Me<sub>5</sub>O<sub>12</sub>, wherein A is a rare earth metal and Me is Fe, Ga, Sc, Cr, Co or Al, e.g. garnets [3]</li> <li>Niobates; Vanadates; Tantalates [3]</li> <li>Titanates; Germanates; Molybdates; Tungstates [3]</li> <li>Silicates [3]</li> <li>Silicates [3]</li> <li>A<sub>III</sub>B<sub>V</sub> compounds [3]</li> <li>Gallium arsenide [3]</li> <li>Gallium phosphide [3]</li> </ul>	31/02 31/04 31/06 31/08 31/10 31/12 31/14 31/16 31/20 31/22 33/00 33/02 33/04 33/06	homogeneous polycrystalline material with defined structure; Apparatus therefor [3,5]  by contacting with diffusion materials in the solid state [3]  by contacting with diffusion materials in the liquid state [3]  by contacting with diffusion material in the gaseous state (C30B 31/18 takes precedence) [3]  the diffusion materials being a compound of the elements to be diffused [3]  Reaction chambers; Selection of materials therefor [3]  Heating of the reaction chamber [3]  Substrate holders or susceptors [3]  Feed and outlet means for the gases; Modifying the flow of the gases [3]  Controlling or regulating [3]  Doping by irradiation with electromagnetic waves or by particle radiation [3]  hy ion-implantation [3]  After-treatment of single crystals or homogeneous polycrystalline material with defined structure (C30B 31/00 takes precedence) [3,5]  Heat treatment (C30B 33/04, C30B 33/06 take precedence) [5]  using electric or magnetic fields or particle radiation [5]  Joining of crystals [5]

33/10 . . in solutions or melts [5]

33/12 . . in gas atmosphere or plasma [5]

Apparatus in general, specially adapted for the growth, production or after-treatment of single crystals or a homogeneous polycrystalline material with defined structure [3,5]